



Patent

Attorney Docket No.: MTI-31470

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Zheng, Lingyi A.
Serial No. : 09/912,041
Confirmation No. : 4539
Filing Date : July 24, 2001
For: : Improved Cell Nitride Nucleation on Insulative Layers and
Reduced Corner Leakage of Container Capacitors

CERTIFICATION UNDER 37 CFR 1.8(a) and 1.10

I hereby certify that, on the date shown below, this correspondence is being:

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37 CFR 1.8(a)

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INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §1.97/98

In compliance with Applicant's duty of disclosure as set forth in 37 C.F.R. §1.56, listed on the attached equivalent to Form PTO-1449 are those patents and other publications known to the Applicant which may be considered material to the patentability of the claims of the above-captioned application.

The Applicant respectfully requests that the documents listed on the attached equivalent to Form PTO-1449 be considered by the Examiner, that these references be made of record in the present applicant, and that an initialed copy of the attached equivalent to Form PTO-1449 be returned to the undersigned in accordance with MPEP 609.

Respectfully submitted,

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Dated: June 15, 2004

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U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE Alexandria, VA 22313 INFORMATION DISCLOSURE STATEMENT BY APPLICANT	ATTY. DOCKET NO.	Serial No.
	MTI-31470	09/912,041
	Applicant	Confirmation No.
	Lingyi A. Zheng	4539
	Filing Date	Group Art Unit
	July 24, 2001	2812

OTHER DOCUMENTS (Including Author, Title, Date, Relevant Pages, Place of Publication)

Examiner Initial		Non-Patent Document
	A1	Van Zant, Peter, <i>Microchip Fabrication, A Practical Guide to Semiconductor Processing</i> , 4 th ed., McGraw-Hill, New York, pp. 337-357 and 363-366 (2000)
	A2	Wolf and Tauber, <i>Silicon Processing for the VLSI Era, Vol. 1: Process Technology</i> , 2 nd ed., Lattice Press, Sunset Beach, Cal., pp. 202-206 and 371-433 (2000)

Examiner Initials	Date Considered
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	